



Docket No.: LBNL 240 US CIP/10513615

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Ka-Ngo LEUNG

Application No.: 10/656,848

Filed: September 6, 2003

For: Negative ION Source With External RF Antenna

Confirmation No.: 8582

Art Unit: 1763

Examiner: Rakesh K. Dhingra

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**COMMENT ON STATEMENT OF REASONS FOR ALLOWANCE**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

There is concurrence with those portions of the issued Examiner's Statement of Reasons for Allowance that in substance reflect that cited references fail to teach, disclose, or suggest, either alone or in combination subject matter recited in allowed claims. Such concurrence also extends to the facts that no allowed claim, in its entirety, reads on any cited reference of record or any permissible combination of such references.

To the extent that the stated reasons for allowance in their entirety or in any other context are asserted in any fashion to contradict or in any way to modify the prior prosecution record for

this application, such assertion is traversed. The prior prosecution record here stands on its own, and as such is complete in providing an adequate record supporting allowance of the pending claims and also in providing for interpretation of such now allowed claims.

Dated: \_\_\_\_\_

*January 3, 2007*

Respectfully submitted,

By \_\_\_\_\_

*Thomas S. Hahn*  
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